

Docket No.: 4590-373

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:	
	:	
Philippe Rommeveaux	:	Confirmation No. 1581
	:	
U.S. Patent Application No. 10/523,808	:	Group Art Unit: 2810
	:	
Filed: February 8, 2005	:	Examiner: Patel, Reema

For: OPTICAL MICROSYSTEM AND FABRICATION PROCESS

AMENDMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated December 5, 2007, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 8 of this paper.